

<b>Notice of References Cited</b>		Application/Control No. 10/047,379	Applicant(s)/Patent Under Reexamination HUANG ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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X	C	US-5719495	02-1998	Moslehi	324/158.1
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Wolf et al., "Silicon Processing for the VLSI Era Vol: 1 Process Technology", Lattice Press, Sunset Beach, CA, USA, pp. 143-145, 1986.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

*Matthew Anderson* 3/5/04